

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. HIROI, et al
Serial No.: 10/062,666
Filed: February 5, 2002
For: PATTERN INSPECTION METHOD AND
SYSTEM THEREFOR
Group: 2881
Examiner: J. Berman
Conf. No.: 4688

SUPPLEMENTAL AMENDMENT

Mail Stop: Amendment (No Fee)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 31, 2009

Sir:

The following Supplemental Amendment is respectfully submitted in connection with the above-identified application, as a supplement to the Amendment filed March 2, 2009. The amendments submitted are as listed below and as set forth on the following pages:

Amendment of the Claims; and

Remarks are included following the amendments.